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	Application No.	Applicant(s)
	09/909,580	BROWN, NATHAN R.
Notice of Allowability	Examiner	Art Unit
	Alvin J Grant	3723
The MAILING DATE of this communication ap All claims being allowable, PROSECUTION ON THE MERITS herewith (or previously mailed), a Notice of Allowance (PTOL-INOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1.3	IS (OR REMAINS) CLOSED in 35) or other appropriate comming RIGHTS. This application is	n this application. If not included unication will be mailed in due course. THIS
1. This communication is responsive to <u>6 July 2004</u> .		
2. The allowed claim(s) is/are 48 and 50-53.		
3. \boxtimes The drawings filed on <u>20 July 2001</u> are accepted by the	Examiner.	
4. ☐ Acknowledgment is made of a claim for foreign priority a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents had 2. ☐ Certified copies of the priority documents had 3. ☐ Copies of the certified copies of the priority International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DAT noted below. Failure to timely comply will result in ABANDOT THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. ☐ A SUBSTITUTE OATH OR DECLARATION must be sull INFORMAL PATENT APPLICATION (PTO-152) which goes the complex of the priority documents had a substitution o	ave been received. ave been received in Application documents have been received. E" of this communication to file NMENT of this application. bmitted. Note the attached EX gives reason(s) why the oath on the submitted.	on No d in this national stage application from the e a reply complying with the requirements AMINER'S AMENDMENT or NOTICE OF r declaration is deficient.
1) hereto or 2) to Paper No./Mail Date (b) nicluding changes required by the attached Examin Paper No./Mail Date Identifying indicia such as the application number (see 37 CFI each sheet. Replacement sheet(s) should be labeled as such in the sheet in	er's Amendment / Comment o R 1.84(c)) should be written on t n the header according to 37 CF	r in the Office action of he drawings in the front (not the back) of FR 1.121(d).
 DEPOSIT OF and/or INFORMATION about the de attached Examiner's comment regarding REQUIREMEN 	POSIT OF BIOLOGICAL MAT IT FOR THE DEPOSIT OF BIO	ERIAL must be submitted. Note the DLOGICAL MATERIAL.
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-946) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SI Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Depos of Biological Material	3) 6. ☐ Interview S Paper No. B/08), 7. ☐ Examiner's	formal Patent Application (PTO-152) ummary (PTO-413), /Mail Date Amendment/Comment Statement of Reasons for Alpwance LEE D. WILSON
		PRIMARY EXAMINER

Examiner's Statement of Reasons for Allowance

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The following is an examiner's statement of reasons for allowance: The art of record considered as a whole or in combination neither anticipates nor renders obvious. a method for planarizing a microelectronic substrate, comprising: biasing a first annular part of the microelectronic substrate against a planarizing medium with a first force by engaging the first annular part with a first portion of a flexible membrane having a first thickness; biasing a second annular part of the microelectronic substrate against the planarizing medium with a second force greater than the first force by engaging the second annular part with a second portion of the flexible membrane having a second thickness greater than the first thickness, the second annular part located in a peripheral region of the microelectronic substrate and the first annular part located in a region of the microelectronic substrate outside the peripheral region. the substrate being held stationary relative to the membrane as the first annular part and the second annular part of the substrate is biased against the planarizing medium: and moving at least one of the microelectronic substrate and the planarizing medium relative to the other to remove material from the microelectronic substrate, together in combination with the rest of the limitations set forth in the dependent claims.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alvin J Grant whose telephone number is (703) 305-3315. The examiner can normally be reached on Mon-Fri 8:00-4:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Joseph J Hail can be reached on (703) 308-2687. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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LEE D. WILSON PRIMARY EXAMINER

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